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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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fifte Application of:

Miyanaga, et al.

Serial No.: 10/045,746

Confirmation No.: 9682

Filed:

October 26, 2001

For: Cleaning Method for Vapor Phase

Deposition Apparatus, and Vapor

Phase Deposition Apparatus

Group Art Unit: 1746

Examiner:

Andrew McAleavey

MAIL STOP AMENDMENT Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

## CERTIFICATE OF MAILING 37 CFR 1.8

I hereby certify that this correspondence is being deposited on <u>January 2 13, 2005</u>, with the United States Postal Service as First Class Mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Signature

## **RESPONSE TO OFFICE ACTION DATED SEPTEMBER 29, 2004**

In response to the Office Action dated September 29, 2004, having an extended statutory period for response set to expire on January 29, 2005, please enter this response and reconsider the claims pending in the application for reasons discussed below. Although Applicant believes that no additional fees are due in connection with this response, the Commissioner is hereby authorized to charge counsel's Deposit Account No. 20-0782/AMAT/5750/KMT, for any fees, including extension of time fees or excess claim fees, required to make this response timely and acceptable to the Office.

Amendments to the Specification begin on page 2 of this paper. Amendments to the Claims are reflected in the listing of claims which begins on page 4 of this paper. Remarks begin on page 6 of this paper.